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Substitute for Form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Complete if Known		
			Application Number	10/660,332	
			Filing Date	Filed Herein	
			First Named Inventor	John R. Clark, et al.	
			Group Art Unit	2817	
			Examiner Name	Barbara Summons	
Sheet	1	of	2	Attorney Docket Number	UOM 0212 PUSP 1

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. PATENT DOCUMENT		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Class/Subclass Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
B2		5,455,547		Lin, et al.	10/03/1995	333/186
B2		5,491,604		Nguyen, et al.	02/13/1996	361/278
B2		5,537,083		Lin, et al.	07/16/1996	333/186
B2		5,589,082		Lin, et al.	12/31/1996	216/2
B2		5,839,062		Nguyen, et al.	11/17/1998	455/323
B2		5,955,932		Nguyen, et al.	09/21/1999	333/186
B2		6,236,281		Nguyen, et al.	05/22/2001	331/154
B2		6,249,073		Nguyen, et al.	06/19/2001	316/309
B2		5,996,409		Funk et al.	12/07/1999	73/504.04
B2		5,194,836		Vale, et al.	3-16-1993	333/133
B2		5,260,675		Ogawa, et al.	11-09-1993	333/189
B2		5,604,392		Vig	2-18-1997	310/309
B2		6,111,338		Otsuchi, et al.	08-29-00	316/352
B2		6,369,374		Greywall	04-09-02	250/201.1
B2		3,612,922		Furnivale	10-12-71	310/351

FOREIGN PATENT DOCUMENTS								
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁵
		Office ³	Number ⁴	Kind Code ⁵ (if known)				

Examiner Signature	Barbara Summons	Date Considered	4/19/04
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Substitute for Form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	10/660,332
				Filing Date	Filed herewith 9/11/03
				First Named Inventor	John R. Clark, et al.
				Group Art Unit	2817
Examiner Name	Barbara Summons				
Sheet	2	of	2	Attorney Docket Number	UOM 0212 PUSP 1

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
BS		JOHNSON, ROBERT A., ET AL., Mechanical Filters In Electronics, pp. v-379, California, January 1983, John Wiley and Sons, New York.	
BS		T. FUJITA et al., "Disk-Shaped Bulk Micromachined Gyroscope With Vacuum Sealing", Sensors and Actuators, 82, 2000, pgs. 198-204, Vol. 82, May 2000.	
BS		GORAN STEMME, "Micro Fluid Sensors and Actuators", Sixth Int'l. Symposium on Micro Machine and Human Science, 1995, pgs. 45-52, October 1995.	
BS		C. T.-C. NGUYEN, "Micromachining technologies for miniaturized communication devices," Proceedings of SPIE: Micromachining and Microfabrication, Sept, 20-22, 1998, pgs. 24-38.	
BS		J.L. DAVIDSON et al., "Diamond as an active sensor material," Diamond and Related Materials, 8, 1999, pgs. 1741-1747, Vol. 8, August 1999.	
BS		C. T.-C. NGUYEN, "Communications applications of microelectromechanical systems," Proceedings, 1998 Sensors Expo, May 19-21, 1998, pgs. 447-455,	

Examiner Signature	Barbara Summons	Date Considered	4/19/04
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